

IN THE UNITED STATES  
PATENT AND TRADEMARK OFFICE

**PATENT APPLICATION**

Applicants: **Davis, et al.**

Case: **6716/ETCH/SILICON**

Serial No.: **10/674,568**

Filed: **September 29, 2003**

Examiner: **Ram N. Kackar**

Group Art Unit: **1763**

Confirmation No.: **3852**

Title: **METHOD AND SYSTEM FOR MONITORING AN ETCH PROCESS**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

S I R:


**NOTICE OF APPEAL**

The Applicants hereby appeal to the Board of Patent Appeals and Interferences from the decision of the Examiner dated June 25, 2008, finally rejecting claims 1, 3, 4, 6-13, 15-18, 20, 21, 23-30, 32-33 and 50-59.

The fee for filing this Notice of Appeal (37 C.F.R. §1.17(b)) is \$510.00. This fee has been paid with the submission of this paper using the Patent Electronic Business Center. The Commissioner is hereby authorized to charge any additional fees due, including extension of time or other fees, to Deposit Account No. 20-0782.

Respectfully submitted,

Sept 22, 2008

  
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